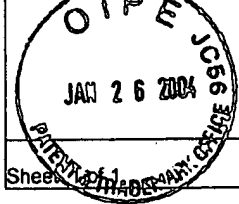


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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
(Use as many sheets as necessary)



Complete if Known

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First Named Inventor Forbes, Leonard  
Group Art Unit 2826  
Examiner Name Dickey, Thomas

Attorney Docket No: 1303.028US1

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**OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS**

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